



Sheet 1 of 1

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## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT  
Hiroyuki NAGASAKAFILING DATE  
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2851

## U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Name
	1	2005/0179877 A1	08/18/2005	MULKENS et al.
	2	2005/0018155 A1	01/27/2005	COX et al.

## FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation
	3	EP 1 524 558 A1	04/20/2005	Europe		
	4	EP 1 498 778 A1	01/19/2005	Europe		
	5	EP 1 528 433 A2	05/04/2005	Europe		
	6	WO 2004/093160 A2	10/28/2004	WIPO		

## OTHER DOCUMENTS

Examiner Initials	Cite No.	Including name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	7	OWA et al., "Immersor Lithography; its potential performance and issues", Proceedings Of Spie, 28 February 2003, pages 724-733, vol. 5040, no. 1, BELLINGHAM, VA.

EXAMINER /Peter Kim/

DATE CONSIDERED 08/04/2009

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.